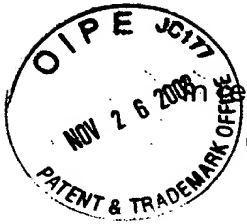


Our Ref.: 3008-0034
File No.: 521.41463X00
Client Ref.: PHCF-01103

PATENT

#17/c
1/8/04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Application of
Oka, et al.

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: Art Unit: 2811

Application S/N 09/925,626

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: Examiner: Shouxiang Hu

Filed: August 10, 2001

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For: CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE,
CRYSTALLINE SILICON FILM PHOTOVOLTAIC DEVICE, AND PROCESS FOR
PRODUCING CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE

PRELIMINARY AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application, prior to examination thereof,
as follows:

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DEC - 2 2003
TECHNOLOGY CENTER 2800